Title: VACUUM PROCESS SYSTEM Inventor(s): Jun OZAWA, et al Application No.: Not yet assigned Docket No.: 285032005901

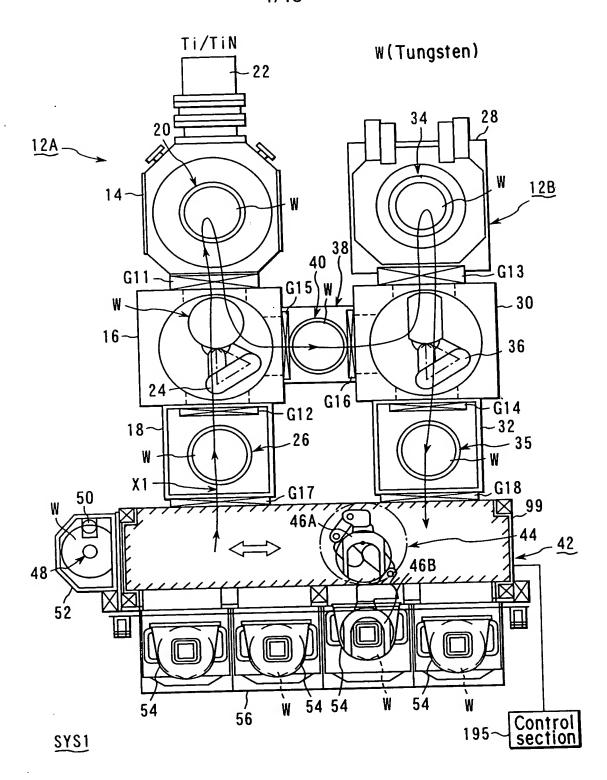


FIG. 1

Title: VACUUM PROCESS SYSTEM Inventor(s): Jun OZAWA, et al Application No.: Not yet assigned Docket No.: 285032005901

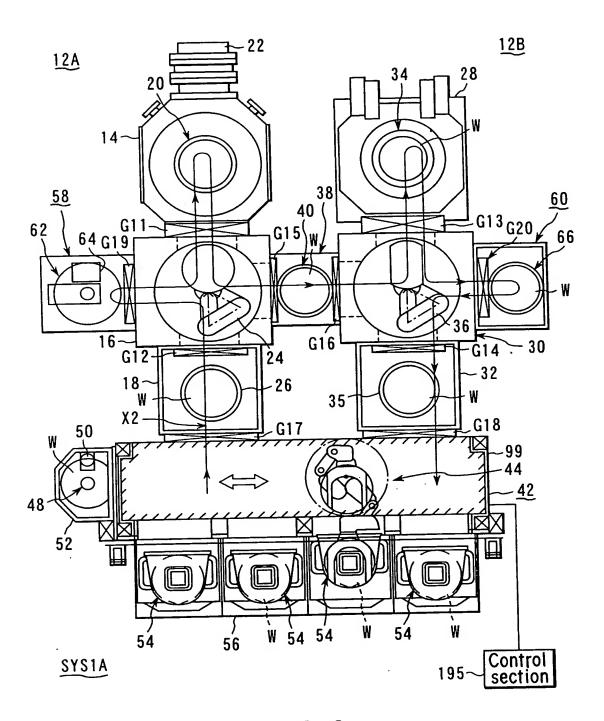


FIG. 2

Inte. VACUUM PROCESS SYSTEM Inventor(s): Jun OZAWA, et al Application No.: Not yet assigned Docket No.: 285032005901

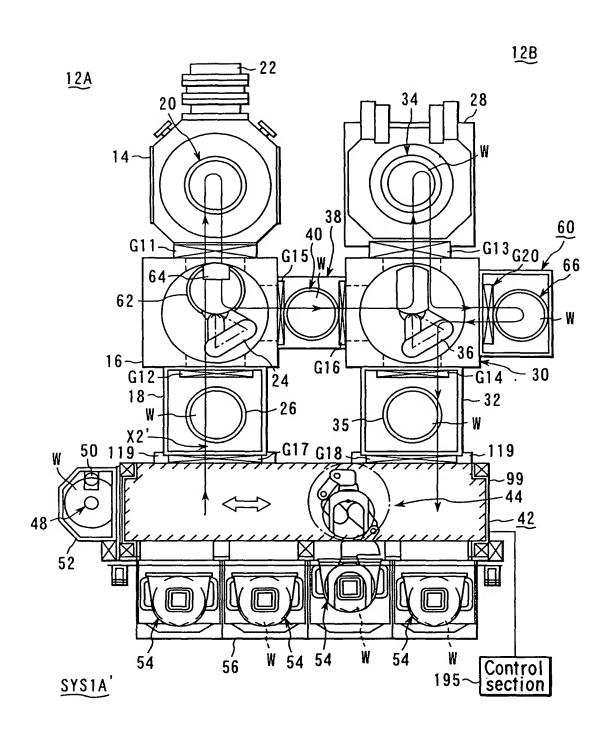
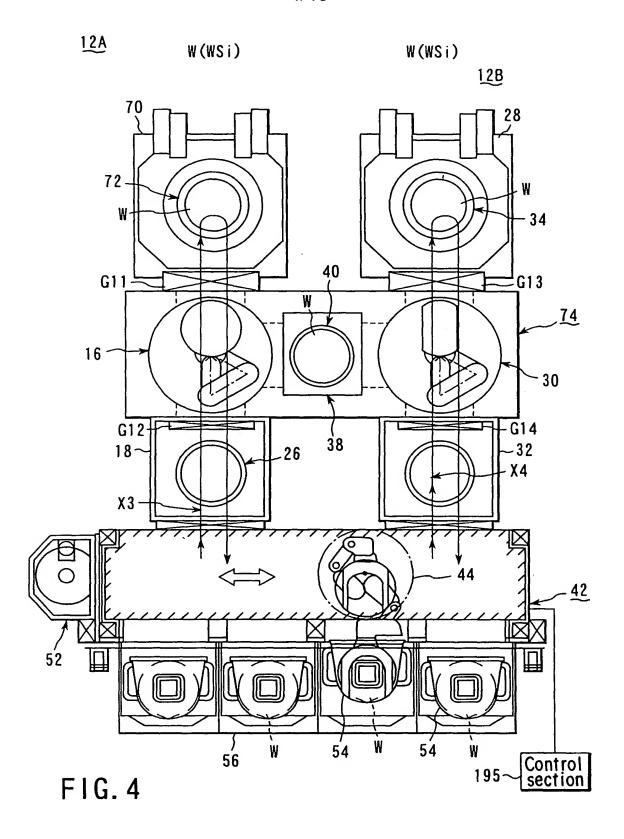
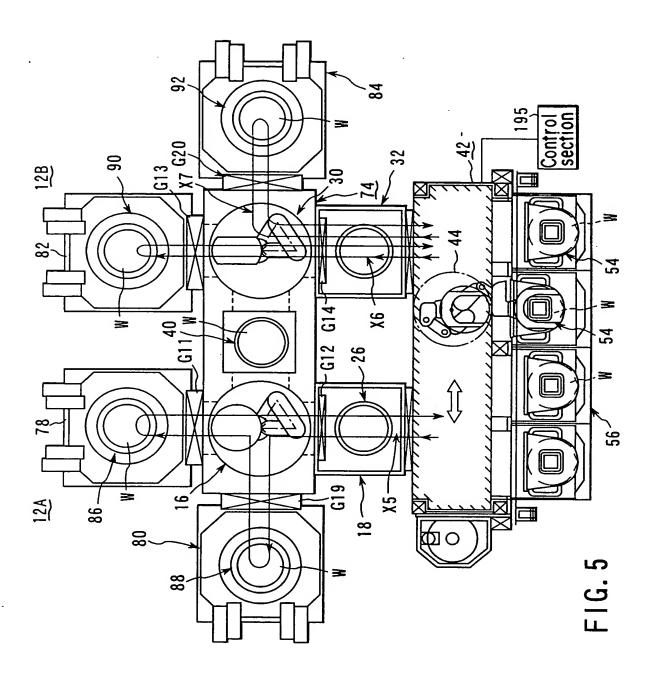


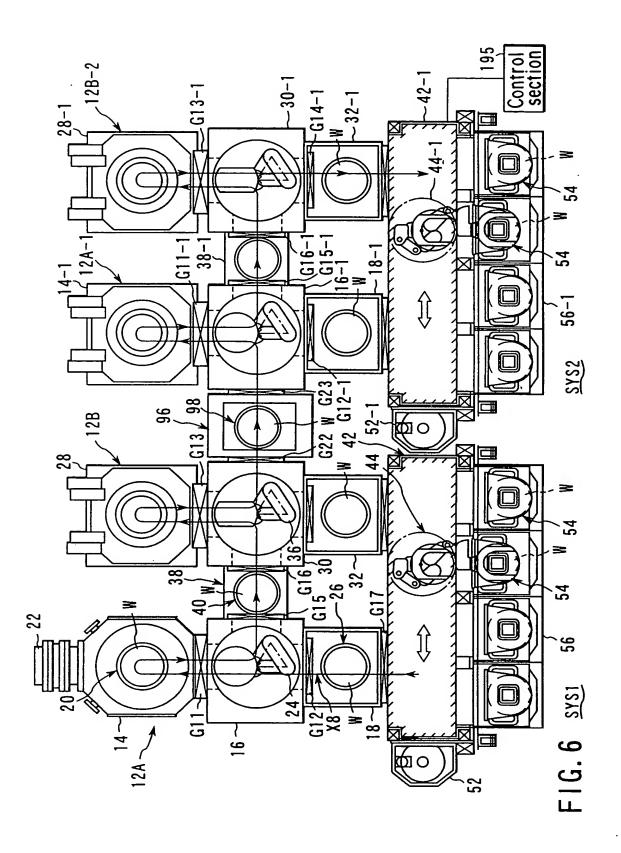
FIG. 3

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Intle: VACUUM PROCESS SYSTEM Inventor(s): Jun OZAWA, et al Application No.: Not yet assigned Docket No.: 285032005901

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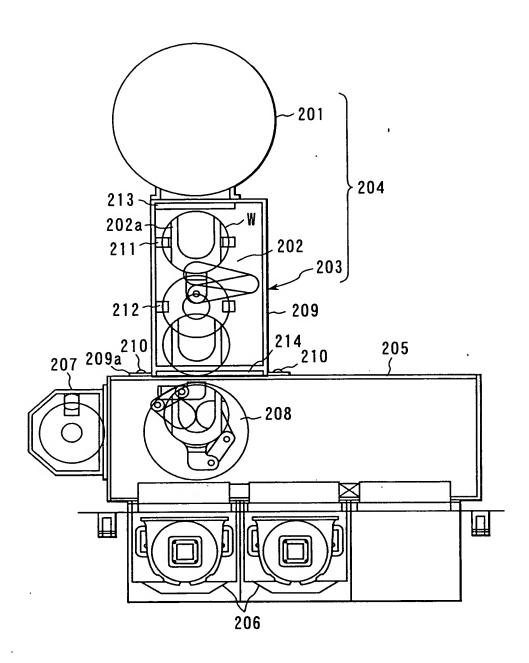


FIG. 7

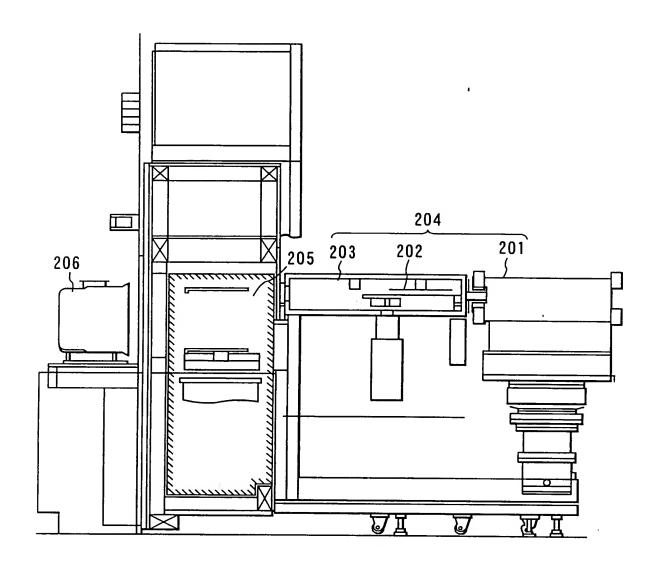
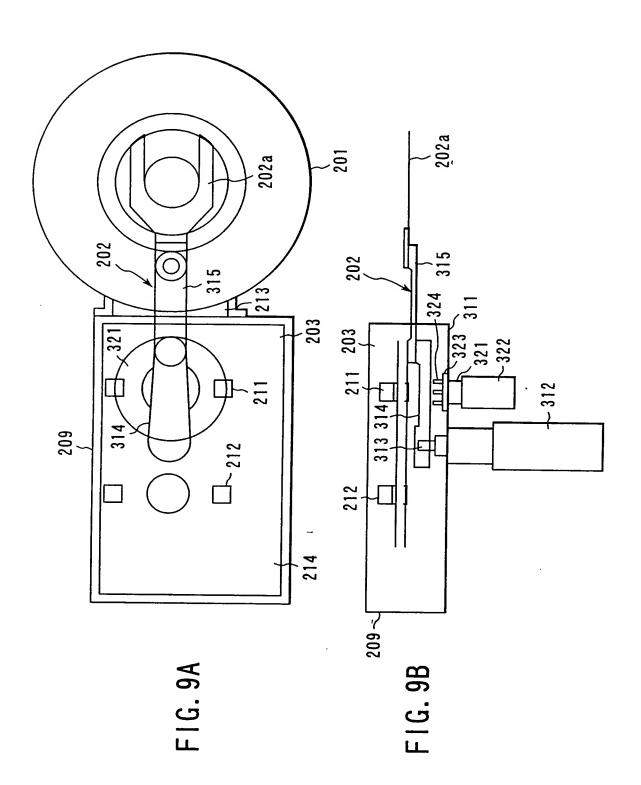


FIG.8

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10/18 F1G. 10K 201 201 FIG. 100 202 203 202 FIG. 10J 202 203 201 201 FIG. 10B 202a 203 203 FIG. 10E 203 W 202a 201 202 203 203 201 203 W 202a 201 201 202a 203

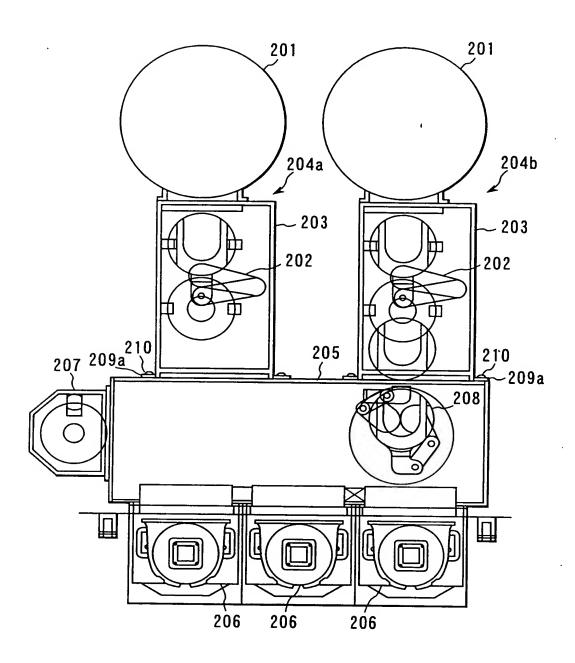
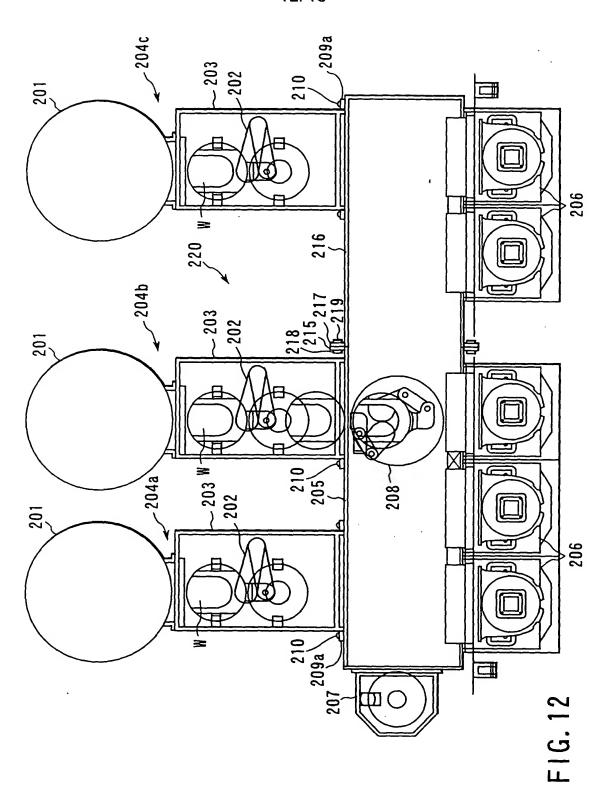
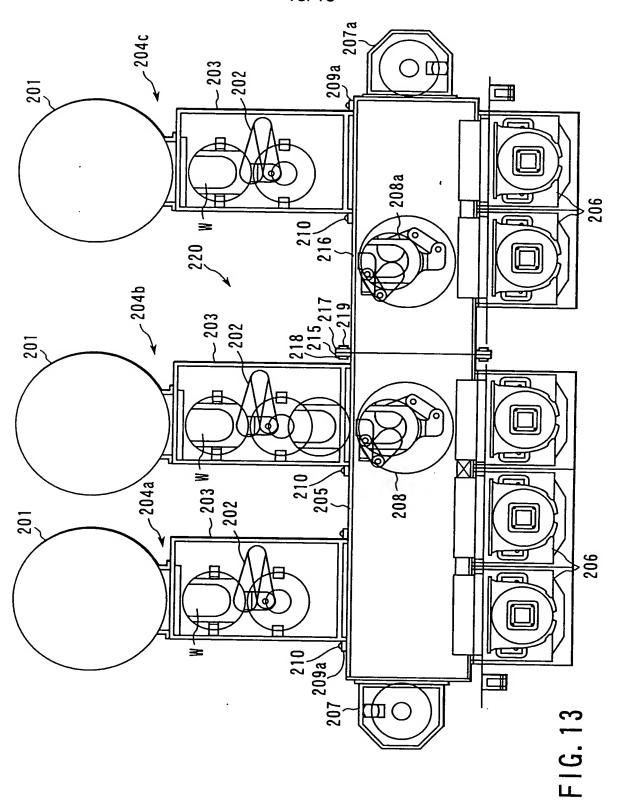


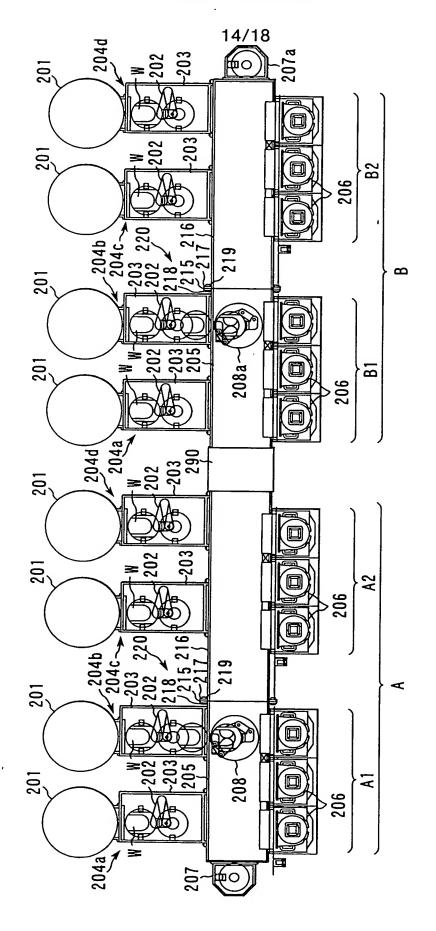
FIG. 11

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F16.14

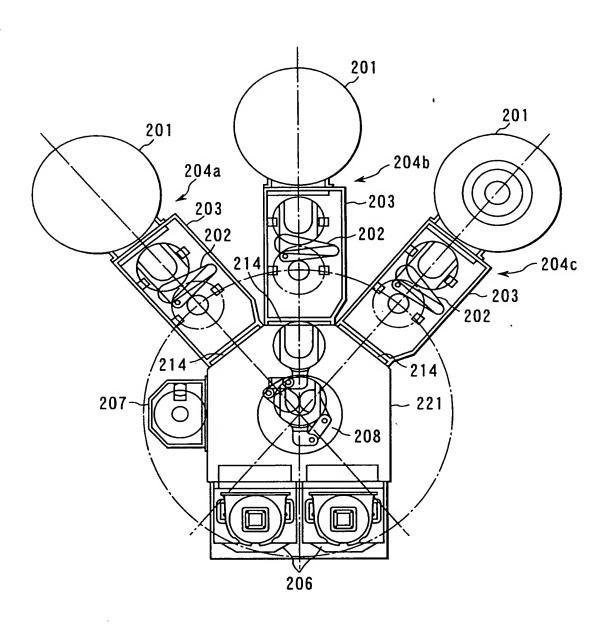


FIG. 15

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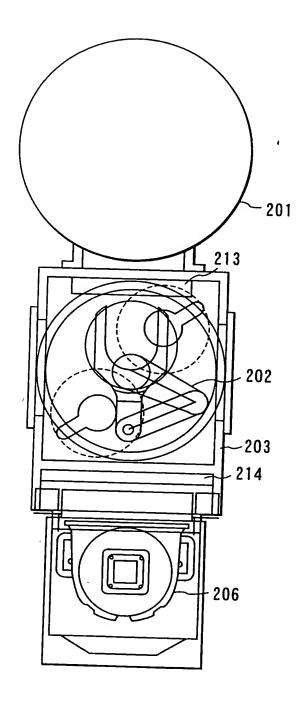


FIG. 16

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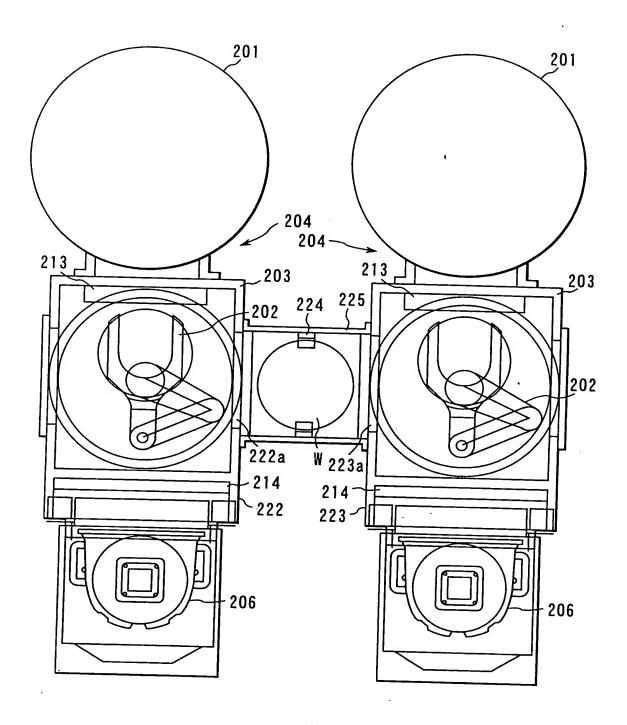


FIG. 17

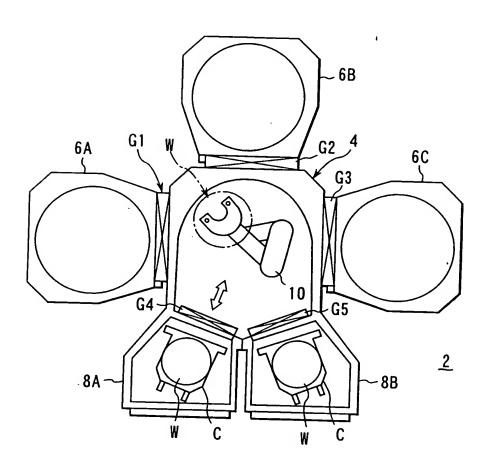


FIG. 18